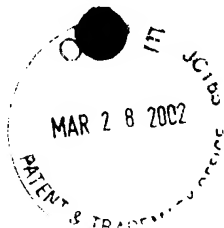


00862.022476



Receipt
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
YOSHIKAZU MIYAJIMA ET AL.) : Examiner: NYA
Application No.: 10/022,506) : Group Art Unit: 2811
Filed: December 20, 2001) :
For: EXPOSURE APPARATUS, DEVICE)
MANUFACTURING METHOD, :
SEMICONDUCTOR)
MANUFACTURING FACTORY, :
AND EXPOSURE APPARATUS)
MAINTENANCE METHOD : March 26, 2002

Office of Initial Patent Examination
Customer Service Center
Commissioner for Patents
Washington, D.C. 20231

REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Applicants' attorneys have received an official Filing Receipt in the above-identified application wherein an error has been noted. The Title is incorrect and should read:

--**Exposure apparatus**, device manufacturing method, semiconductor manufacturing factory, and exposure apparatus maintenance method--.

A copy of the official Filing Receipt is attached with the proposed change marked in red. Issuance of a Corrected Filing Receipt with the correct data is accordingly respectfully requested.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Donald A. Canto", written over a horizontal line.

Attorney for Applicants

Registration No. 26.718

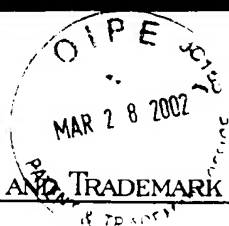
FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
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MAR 12 2002



APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
10/022,506	12/20/2001	2811	1502	862.C2476	33	39	8

CONFIRMATION NO. 2840

05514

FITZPATRICK CELLA HARPER & SCINTO
30 ROCKEFELLER PLAZA
NEW YORK, NY 10112

FILING RECEIPT



OC00000007385526

00862-022476
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Date Mailed: 01/30/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Yoshikazu Miyajima, Tochigi, JAPAN;
Kazuhito Outuka, Tokyo, JAPAN;
Keiji Emoto, Kanagawa, JAPAN;

Domestic Priority data as claimed by applicant

Foreign Applications

JAPAN 2000-395819 12/26/2000

If Required, Foreign Filing License Granted 01/29/2002

Projected Publication Date: 06/27/2002

Non-Publication Request: No

Early Publication Request: No

Title

Exposure apparatus, device manufacturing method, semiconductor manufacturing factory, and exposure apparatus maintenance method

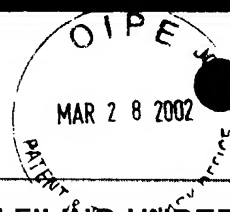
Preliminary Class

257

TECH

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2002



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Bib Data Sheet

CONFIRMATION NO. 2840

SERIAL NUMBER 10/022,506	FILING DATE 12/20/2001 RULE	CLASS 257 355	GROUP ART UNIT 281 2851	ATTORNEY) DOCKET NO. 862.C2476
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APPLICANTS

Yoshikazu Miyajima, Tochigi, JAPAN;
 Kazuhito Outuka, Tokyo, JAPAN;
 Keiji Emoto, Kanagawa, JAPAN;

** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

JAPAN 2000-395819 12/26/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 01/29/2002

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 33	TOTAL CLAIMS 39	INDEPENDENT CLAIMS 8
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

ADDRESS

05514

TITLE

Exposure apparatus, device manufacturing method, semiconductor manufacturing factory, and exposure
 apparatus maintenance method

FILING FEE RECEIVED 1502	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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		<input type="checkbox"/> Other _____
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